

501.40205X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants: KOHNO et al.

Serial No.: 09/925,375

Filed: August 10, 2001

For: SEMICONDUCTOR DEVICE TESTING APPARATUS AND  
SEMICONDUCTOR DEVICE MANUFACTURING METHOD  
USING IT

4 / IDS  
E. Millio  
11-20-01

INFORMATION DISCLOSURE  
STATEMENT UNDER 37 CFR 1.97 & 1.98

Honorable Commissioner of  
Patents and Trademarks  
Washington, D.C. 20231

September 6, 2001

Sir:

In the matter of the above-identified application, applicant(s) is/are submitting herewith copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration. This information disclosure statement is being submitted within three months of the filing date.

To the extent the documents listed on the attached form equivalent to Form PTO-1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by the discussion of these documents in the specification, for example, page 5.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

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180.00 DP

A credit card payment form to cover the fee of \$240.00 under 37 CFR 1.17(p) is enclosed.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus Deposit Account No. 01-2135 (Case:500.40205X00), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



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Reference(s) cited in the case

Prior U.S. Applications

Prior Publications

(1) Japanese Patent Unexamined Pub. No.7-7052/1995

(2) Japanese Patent Unexamined Pub. No.11-274251/1999